

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re expolication of:

Cheung, et al.

Serial No.: 10/648,616

Filed:

August 26, 2003

Confirmation No.: 4378

For:

Plasma Processes for Depositing Low Dielectric

Constant Films

Commissioner for Patents Office of Initial Patent Examination Filing Receipt Corrections P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1765

Examiner:

Unknown

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office, Office of Initial Patent Examination, Fax No. (703) 746-9195, on the date below.

/ - 0/) Date

Signature/

REQUEST FOR CORRECTION OF ERROR ON FILING RECEIPT

The Filing Receipt for the above-referenced application contains an error regarding the Applicant(s) place of residence. Please correct the filing receipt as identified below:

David Cheung, Foster City, <u>CANADA</u>; should read David Cheung, Foster City, <u>CA</u> Shin-Puu Jeng, Hsinchu, <u>CA</u>; should read Shin-Puu Jeng, Hsinchu, <u>TAIWAN</u>

Attached is a copy of the Filing Receipt with the above changes noted thereon.

Please correct this error or notify the Applicants of the reasons for denying the request.

Respectfully submitted,

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CONFIRMATION NO. 4378

APPLIED MATERIALS, INC. Patent Counsel P.O. Box 450-A Santa Clara, CA 95052



FILING RECEIPT OC000000011305513

Date Mailed: 11/19/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE. NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

Applied Materials, Inc.;

Domestic Priority data as claimed by applicant

√This application is a CON of 09/957,551 09/19/2001 Which is a CON of 09/247,381 02/10/1999 PAT 6,348,725 which is a CIP of 09/021,788 02/11/1998 PAT 6,054,379 √and is a CIP of 09/114,682 07/13/1998 PAT 6,072,227 ✓and is a CIP of 09/162,915 09/29/1998 PAT 6,287,990 √and is a CIP of 09/185,555 11/04/1998 PAT 6,303,523

Foreign Applications